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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Khalil Najafi, et al.

Group Art Unit: 2822

Serial No.: 10/688,417

Examiner:

Filed: October 17, 2003

For: MANUFACTURING METHODS AND VACUUM OR HERMETICALLY
PACKAGED MICROMACHINED OR MEMS DEVICES

Attorney Docket No.: UOM 0281 PUSP

STATUS INQUIRY

Commissioner for Patents
U.S. Patent & Trademark Office
P.O. Box 1450
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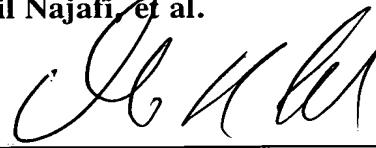
Sir:

Please inform us of the status of the above-identified patent application and as to when we may expect an Office Action from the U.S. Patent and Trademark Office.

Respectfully submitted,

Khalil Najafi, et al.

By:



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